

Docket No.: EHF 2001,0167 P



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Norbert Benesch et al.
Appl. No. : 09/873,230
Filed : June 4, 2001
Title : Method and Device for Optically Monitoring Fabrication
Processes of Finely Structured Surfaces in a Semiconductor
Production
Art Unit :

ASSOCIATE POWER OF ATTORNEY

Hon. Commissioner of Patents and Trademarks,
Washington, D.C. 20231

Sir:

Please recognize GREGORY L. MAYBACK (Reg. No. 40,719) as my associate in the matter in the above-identified application, with full powers. Please continue addressing all communications to the following address:

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Respectfully submitted,

A handwritten signature in black ink, appearing to read "Werner H. Stemer".

For Applicant(s)

WERNER H. STEMER
RL 34,956

Date: August 8, 2001

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/mjb